



S/N 09/858337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	William J. Schaff et al.	Examiner:	Khanh Duong
Serial No.:	09/858337	Group Art Unit:	Unknown
Filed:	May 15, 2001	Docket No:	1153.044US1
Title	AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING		

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#8  
#11/19/03  
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PETITION FOR A TWO-MONTH EXTENSION OF TIME

Commissioner for Patents  
Washington, D.C. 20231

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a two-month extension of time be granted in which to respond to the Office Action mailed November 4, 2002, said period of response being extended from February 4, 2003 to April 4, 2003.

**Our check in the amount of \$205.00 is enclosed to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.**

Respectfully Submitted

WILLIAM J. SCHAFF ET AL.

By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A  
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04/07/2003 TBESHAH1 00000078 09858337

01 FC:2252 205.00 OP

Date: 3-28-2003

By: \_\_\_\_\_

Bradley A. Forrest

Reg. No: 30,837

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelop addressed to: Commissioner for Patents, Washington, D.C. 20231, on this 28th day of March 2003

Name: \_\_\_\_\_

Signature: \_\_\_\_\_